



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto, et al.

Art Unit : 2823

Serial No. : 10/025,322

Examiner : Julio J. Maldonado

Filed : December 18, 2001

Confirmation No.: 2823

Title : LASER ANNEALING METHOD AND LASER ANNEALING DEVICE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

RECEIVED
JUL 25 2003
TECHNOLOGY CENTER 2800

RESPONSE TO ELECTION OF SPECIES REQUIREMENT

Responsive to the action mailed June 24, 2003, applicants elect the invention of Species II, directed to a method of manufacturing a semiconductor film including preheating said semiconductor film to form an oxide film and applying a laser beam to said semiconductor film through said oxide film to form a crystalline semiconductor film in a nitrogen atmosphere. Claims 4-12 and 16-26 are readable on the species and claims 1-3 are generic. The election is made without traverse.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: July 24, 2003


John F. Hayden
Reg. No. 37,640

Customer No. 26171

Fish & Richardson P.C.

1425 K Street, N.W.

11th Floor

Washington, DC 20005-3500

Telephone: (202) 783-5070

Facsimile: (202) 783-2331